

PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Weimer, Ronald A.
Serial No. : 09/941,827
Filing Date : August 29, 2001
For : Method of Improved High K Dielectric-Polysilicon Interface for CMOS Devices
Examiner: HUYNH, Yennhu B.
Group Art Unit 2813
Confirmation No.: 7551

CERTIFICATION UNDER 37 CFR 1.8(a) and 1.10

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Date: Sept 4, 01 

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

Applicant requests consideration of the pending claims in the above-identified patent application based on the remarks herein.

Remarks begin on page 2 of this paper.